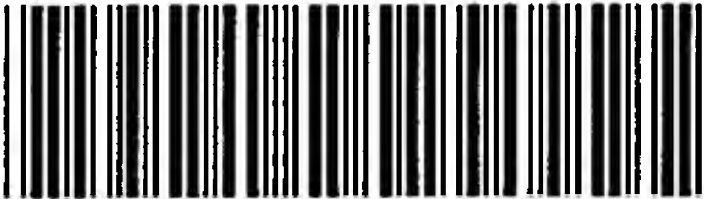


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/604,820	CHI, CHAO-WEN	
	Examiner	Art Unit	
	Jeffrey Donels	2837	

SEARCHED			
Class	Subclass	Date	Examiner
84`	645	12/12/2005	JWD

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
brs text updated	12/12/2005	JWD